



CERTIFICATE OF MAILING 27805  
PATENT TRADEMARK OFFICE

I hereby certify that this correspondence is being deposited in the  
United States Postal Service as first class mail in the envelope  
addressed to: Assistant Commissioner for Patents, Washington,  
D.C., 20231, on

11/26/04

Date of Deposit

Attorney

41,733  
Reg. No.

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:

Applicant : Alain Izadnegahdar et al.  
Serial No. : 09/908,847  
Filed : July 20, 2001  
Title : THIN PIEZO RESISTIVE PRESSURE SENSOR  
Docket No. : 015559-250  
Art Unit : 2855

Commissioner for Patents  
Washington, D.C. 20231

RECEIVED

JUN 07 2004

TECHNOLOGY CENTER R3700

INFORMATION DISCLOSURE STATEMENT

Pursuant to 37 C.F.R. §1.56, the Examiner's attention is directed to the references listed on the attached Information Disclosure Citation, copies of which are attached.

It is to be understood that the present submission of art is in no way intended to be a waiver of any arguments or defenses available to the applicant under the rules of the U.S. Patent and Trademark Office and the statutes of the United States.

No fee is required. The Commissioner is authorized to charge any additional fees required by this paper or to credit any overpayment to Deposit Account No. 20-0809.

Respectfully submitted:

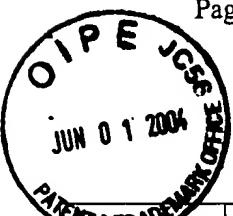
By:

Steven J. Elleman  
Reg. No. 41,733

THOMPSON HINE LLP  
2000 Courthouse Plaza N.E.  
10 West Second Street  
Dayton, Ohio 45402-1758  
Telephone: (937) 443-6838  
Facsimile: (937) 443-6635

## INFORMATION DISCLOSURE CITATION

Page 1 of 2 Pages



Docket: 015559-250	Serial. No.: 09/909,847
Applicant: Alain Izadnegahdar et al.	
Filed: 7/20/01	Group: 2855

## U.S. PATENT DOCUMENTS

Examiner	Document No.	Date	Name	Class	Sub	
	4,023,562	05/77	Hynecek et al.			
	4,882,933	11/89	Petersen et al.			
	5,231,301	07/93	Peterson et al.			
	5,355,712	10/94	Petersen et al.			
	5,461,922	10/95	Koen			
	5,706,565	01/98	Sparks et al.			
	5,902,248	05/99	Millar et al.			
	6,019,729	02/00	Itoigawa et al.			
	6,038,928	03/00	Maluf et al.			

RECEIVED  
JUN 07 2004  
TECHNOLOGY CENTER R3700

## FOREIGN PATENT DOCUMENT

Trans

Examiner	Document No.	Date	Country	Class	Sub	Y	N

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	E. Kälvesten, <i>The First Surface Micromachined Pressure Sensor for Cardivascular Pressure Measurements</i> , IEEE, pp. 574-579 (1998)
	Hin-Leung Chau, <i>An Ultraminiature Solid-State Pressure Sensor for a Cardiovascular Catheter</i> , IEEE Transactions on Electron Devices, Vol. 35, No. 12, pp. 2355-2362 (1988)

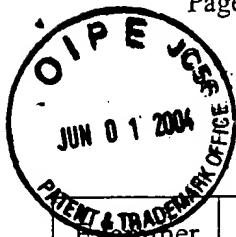
Examiner:

Date Considered:

\* Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609.  
 Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

## INFORMATION DISCLOSURE CITATION

Page 2 of 2 Pages



Docket: 015559-250	Serial. No.: 09/909,847
Applicant: Alain Izadnegahdar et al.	
Filed: 7/20/01	Group: 2855

## U.S. PATENT DOCUMENTS

Examiner	Document No.	Date	Name	Class	Sub	
	6,084,257	07/00	Petersen et al.			
	6,106,476	08/00	Corl et al.			
	6,140,143	10/00	Christel et al.			
	6,167,763	01/01	Tenerz et al.			

RECEIVED  
JUN 07 2004  
TECHNOLOGY CENTER H37

## FOREIGN PATENT DOCUMENT

Trans

Examiner	Document No.	Date	Country	Class	Sub	Y	N

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


Examiner: Date Considered:

\* Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609.  
 Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.